

Notice of References Cited		Application/Control No. 09/785,424	Applicant(s)/Patent Under Reexamination PARK ET AL.	
		Examiner David Chung	Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,124,911	09-2000	Nakamura et al.	349/113
	B	US-6,081,310	06-2000	Katsuya et al.	349/113
	C	US-			
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	I	US-			
	J	US-			
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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